

<b>Notice of References Cited</b>	Application/Control No. 10/541,034		Applicant(s)/Patent Under Reexamination SHIMAWAKI ET AL.	
	Examiner Shih-Chao Chen		Art Unit 2821	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0027586	02-2003	Johnson et al.	455/517
*	B	US-4,972,199	11-1990	Raghavan et al.	343/756
*	C	US-4,498,061	02-1985	Morz et al.	333/21A
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
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**NON-PATENT DOCUMENTS**

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